

S/N 09/945,553



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fernando Gonzalez et al. Examiner: George R Fourson
Serial No.: 09/945,553 Group Art Unit: 2823
Filed: August 30, 2001 Docket: 303.775US1
Title: METHOD TO CHEMICALLY REMOVE METAL IMPURITIES FROM
POLYCIDE GATE SIDEWALLS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. § 1.97(c)(2), Applicants hereby authorize the Commissioner to charge the fee of \$180.00 as set forth in 37 C.F.R. § 1.17(p), to Deposit Account No. 19-0743. Please charge any additional fees or credit any overpayment to Deposit Account No. 19-0743.

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The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

Pursuant to 37 C.F.R. 1.98(a)(2), Applicant believes that copies of cited U.S. Patents and Published Applications, and Non-Published Applications identifiable by USPTO Serial Number, are no longer required to be provided to the Office. Notification of this change to this effect was provided in the United States Patent and Trademark Office OG Notices dated October 12, 2004 and October 19, 2004. Thus, Applicant has not included copies of any US Patents or US Patent Applications identifiable by serial number that may be cited with this submission. Should the Office require copies to be provided, Applicant respectfully requests that notice of such requirement be directed to Applicant's below-signed representative. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

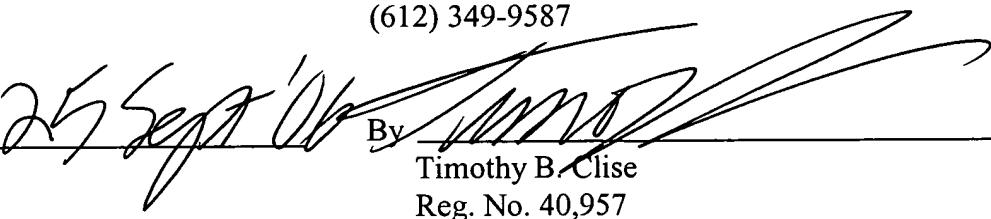
Respectfully submitted,

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By their Representatives,

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Date

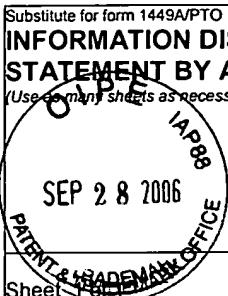

By 
Timothy B. Clise
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 25 day of September 2006.

Name




Signature

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)  Sheet 1 of 1		Complete if Known Application Number 09/945,553 Filing Date August 30, 2001 First Named Inventor Gonzalez, Fernando Group Art Unit 2823 Examiner Name Fourson, George	
		Attorney Docket No: 303.775US1	

US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
	US-20050104114A1	05/19/2005	Chen, C., et al.	11/17/2003
	US-5,039,349	08/13/1991	Schoeppel, J. F.	05/18/1990
	US-5,830,802	11/03/1998	Tseng, H-H , et al.	08/31/1995
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	US-6,153,509	11/28/2000	Watanabe, K., et al.	06/30/1999
	US-6,313,003	11/06/2001	Chen, H-S	08/17/2000
	US-6,429,105	08/06/2002	Kunikiyo, T.	07/10/2000

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	T ²

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		WOLF, S., <u>Silicon Processing for the VLSI Era, (1), Process Technology</u> , (1986),514-517 and 551-552	

EXAMINER

DATE CONSIDERED